2 eceipt

PATENT

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Date

Title

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Vishnu K. Agarwal and

Attorney Docket No.: 500453.04

Scott G. Meikle

Group Art Unit · 1762

Serial No. : 09/970.100 Filed

: October 2, 2001 : POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL AND

CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND USING SUCH

PADS AND MACHINES

REQUEST FOR CORRECTED FILING RECEIPT

Office of Initial Patent Examination Customer Corrections Branch Commissioner of Patents Washington, D.C. 20231

Sir:

Attached is a copy of the official Filing Receipt received from the PTO in the above-identified application, for which issuance of a corrected Filing Receipt is respectfully requested.

There is an error with respect to the following data, which is incorrectly entered. There is an error in the name of one of the applicants, which should read Vishnu K. Agarwal, rather than Argarwal.



The correction to be made has been marked in red on the copy of the enclosed Filing Receipt.

Respectfully submitted,

DORSEY & WHITNEY LLP

Steven H. Arterberry Registration No. 46,314

Enclosure:

Postcard Copy of Filing Receipt Copy of Declaration

1420 Fifth Avenue, Suite 3400 Seattle, WA 98101 Tel: (206) 903-8800 Fax: (206) 903-8820

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ICATION NUMBER 09/970.100

FILING DATE 10/02/2001

1762

GRP ART UNIT | FIL FEE REC'D | ATTY.DOCKET.NO | DRAWINGS 500453.04 992

CONFIRMATION NO. 2699

W & TRACEDORSEY & WHITNEY LLP SUITE 3400 1420 FIFTH AVENUE SEATTLE, WA 98101

FILING RECEIPT

OC000000006971125*

Date Mailed: 10/25/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Agarwal

Vishnu K. Argarwal, Boise, ID; Scott G. Meikle, Boise ID:

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A CON OF 09/621,021 07/21/2000 WHICH IS A DIV OF 09/201.576 11/30/1998 PAT 6.206.759

Foreign Applications

If Required, Foreign Filing License Granted 10/24/2001

Projected Publication Date: 01/31/2002

Non-Publication Request: No

Early Publication Request: No

Title

Polishing pads and planarizing machines for mechanical or chemical-mechanical planarization of microelectronic device substrate assemblies, and methods for making and using such pads and machines

Preliminary Class

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